



**ELECTRONIC COPY**

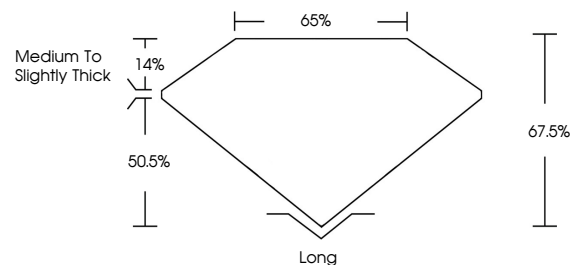
LG784660244  
Report verification at igi.org



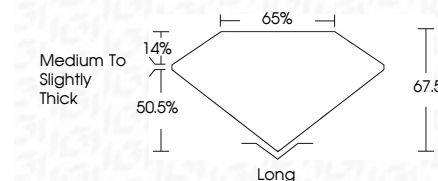
March 23, 2026  
IGI Report Number **LG784660244**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **8.47 X 5.73 X 3.87 MM**  
**GRADING RESULTS**  
Carat Weight **1.85 CARAT**  
Color Grade **D**  
Clarity Grade **VVS 1**

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**PROPORTIONS**



Sample Image Used



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG784660244**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

| FL       | IF                  | VVS <sup>1-2</sup>          | VS <sup>1-2</sup>      | SI <sup>1-2</sup> | I <sup>1-3</sup> |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included         |



**IGI**



March 23, 2026  
IGI Report No **LG784660244**  
**EMERALD CUT**  
Carat Weight **1.85 CARAT**  
Color Grade **D**  
Clarity Grade **VVS 1**  
Table **67.0%**  
Girdle **65%**  
Medium to Slightly Thick  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG784660244**  
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